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Application Number	Not Yet Assigned
Confirmation Number	
Filing Date	November 25, 2003
First Named Inventor	Eric J. BERGMAN
Group Art Unit	
Examiner Name	
Attorney Docket No.	54008.8100.US01 (P01-0015US2)

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Examiner	Cite	Kind C	ahn	Name of Patentee or Inventor	Filing Date of Cited	Pages, Columns, Lines, Where Relevant Passages or					
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First Named Inventor	Eric J. BERGMAN
Group Art Unit	
Examiner Name	
Attomey Docket No.	54008.8100.US01 (P01-0015US2)

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COMPLETE IF KNOWN Application Number 10/721,495 Confirmation Number 10/721,495 Confirmation Number Filing Date November 25, 2003 Form SB/08A (Use several sheets if necessary) Group Art Unit Examiner Name 1 of 1 Attorney Docket No. 54008.8100.US01 (P01-0015US2)

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	ું જે	STATEMENT E	BY APPLICANT		Filing Date	November 25, 2003
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	ıminer tials*			Code	Name of Patentee or Inventor of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines Where Relevant Passage Relevant Figures Appe	s or		
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First Named Inventor	Michael KENNY		
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		OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS	
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Confirmation Number	6048	
Filing Date	November 25, 2003	
First Named Inventor	Michael Kenny	
Group Art Unit 1746		
Examiner Name	Frankie L. Stinson	
Attorney Docket No.	54008.8100.US01 (P05-0015US2)	

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